


<b>Search Notes</b> 	<b>Application/Control No.</b> 10660910	<b>Applicant(s)/Patent Under Reexamination</b> MICKE ET AL.
	<b>Examiner</b> Patidar, Jay M	<b>Art Unit</b> 2862

SEARCHED			
Class	Subclass	Date	Examiner

SEARCH NOTES		
Search Notes	Date	Examiner
Search updated. EAST searched.	3/30	JP
Consulted Primary Examiner Bentsu Ro in class 318.		

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner
324	177	3/30	JP